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Speaker: **Linyong (Leo) Pang 1, Ezequiel Vidal Russell 2, Bill Baggenstoss 2, Yang Lu 2, Michael Lee 2, Jennefir Digaum 2, Ming-Chuan Yang 2, Ryan Pearman 1, P.Jeffrey Ungar 1, Lu Sha 1, Ali Bouaricha 1, Michael Pomerantsev 1, Mariusz Niewczas 1, Kechang Wang 1, Bo Su 1, Michael Meyer 1, Aki Fujimura 1, 1 D2S and 2 Micron Technol., USA**

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2-6: NanoTool	3: Nanoimprint、Hybrid-NIL、Biomimetics、and Functional Surfaces	4: BioMEMS、Lab on a Chip、and Nanobiotechnology	5: Microsystem Technology and MEMS
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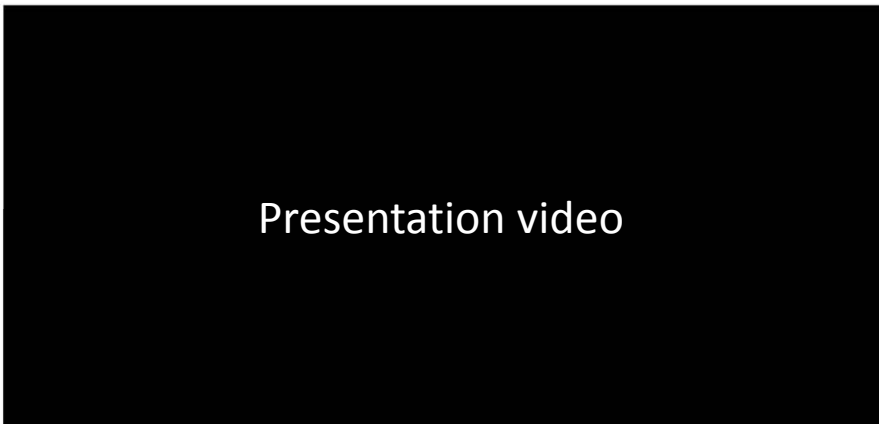
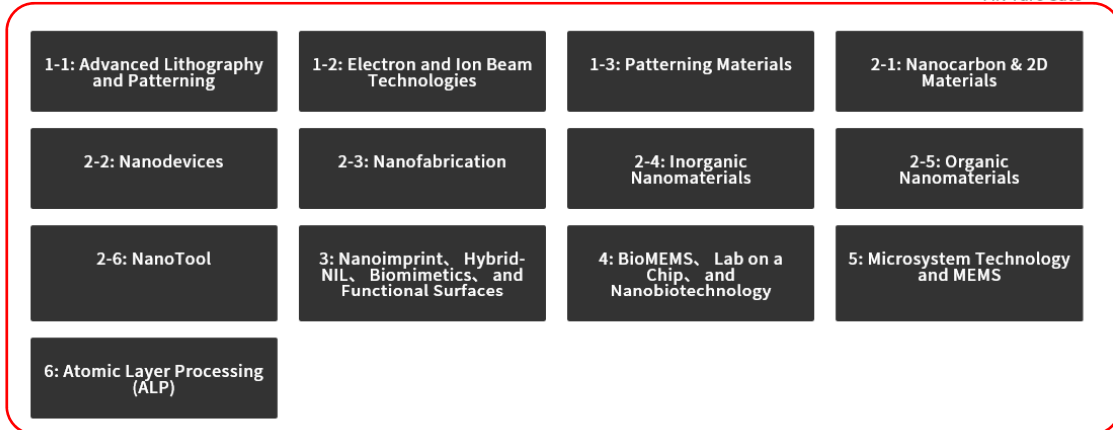**Full Chip Curvilinear ILT with both Multi-Beam and VSB Mask Writers That Improves Wafer Process Windows by 2X (Special Talk)**

Linyong (Leo) Pang 1, Ezequiel Vidal Russell 2, Bill Baggenstoss 2, Yang Lu 2, Michael Lee 2, Jennefir Digaum 2, Ming-Chuan Yang 2, Ryan Pearman 1, P.Jeffrey Ungar 1, Lu Sha 1, Ali Bouaricha 1, Michael Pomerantsev 1, Mariusz Niewczas 1, Kechang Wang 1, Bo Su 1, Michael Meyer 1, Aki Fujimura 1, 1 D2S and 2 Micron Technol., USA

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